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**SUPPLEMENTAL INFORMATION DISCLOSURE
 STATEMENT BY APPLICANT**

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Atty. Docket No.
P30564US

Serial No.
09/822,115

Applicant
Roald G. van Borselen

Examiner Name
Anthony Gutierrez

Filing Date
3/30/2001

Group
2862

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U.S. Patent Documents

| Exam. Init. | Cite No. | Document Number | Publication Date | Name of Patentee or Applicant of Cited Document | Pages, Columns, Lines, Where Relevant Passages or Relevant Figures Appear |
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| | A20 | | | | |

Examiner:

Anthony Gutierrez

Date Considered:

1/24/03

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| | B1 | | | | | | |
| | B2 | | | | | | |
| | B3 | | | | | | |
| | B4 | | | | | | |
| | B5 | | | | | | |

Other Art (Including Author, Title, Date Pertinent Pages, Etc.)

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| AG | C1 | Sheriff, R., Surface-Related Multiple Elimination, an Inversion Approach, Encyclopedic Dictionary of Exploration Geophysics Third edition, 1 Geophysical References Series, 1991, pp. cover page, title page, copyright page, pages 1 and 18. |
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| | C3 | |
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| | C6 | |
| | C7 | |
| | C8 | |
| | C9 | |
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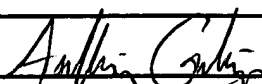
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